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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
09/899,183	07/06/2001	Shigeru Matsuno	401278	3158	
	590 11/04/2004		EXAM	EXAMINER	
LEYDIG VOIT & MAYER, LTD 700 THIRTEENTH ST. NW		•	BUEKER, RICHARD R		
SUITE 300			ART UNIT	PAPER NUMBER	
WASHINGTO	J, DC 20005-3960		1763		
			DATE MAILED: 11/04/2004	1	

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)		
Office Action Summary		09/899,183	MATSUNO ET AL.		
Office Action Sum	iliai y	Examiner	Art Unit		
The MAU INC DATE of this		Richard Bueker	1763		
The MAILING DATE of this Period for Reply	communication app	ears on the cover sheet w	ith the correspondence add	ress	
A SHORTENED STATUTORY PI THE MAILING DATE OF THIS CO Extensions of time may be available under the after SIX (6) MONTHS from the mailing date If the period for reply specified above, the Failure to reply within the set or extended per Any reply received by the Office later than the earned patent term adjustment. See 37 CFR	OMMUNICATION. The provisions of 37 CFR 1.13 of this communication. Than thirty (30) days, a reply maximum statutory period we riod for reply will, by statute, The months after the mailing The months after the mailing	old(a). In no event, however, may a r within the statutory minimum of thin ill apply and will expire SIX (6) MON	eply be timely filed y (30) days will be considered timely. THS from the mailing date of this con	nmunication.	
Status	•				
1) Responsive to communicati	ion(s) filed on 07 Ju	lv 2004			
2a) ☐ This action is FINAL . 2b) ☑ This action is non-final.					
3) Since this application is in c	condition for allowan	ce except for formal matt	ers, prosecution as to the r	merits is	
closed in accordance with the	he practice under <i>E.</i>	x parte Quayle, 1935 C.D	. 11, 453 O.G. 213.	nonto to	
Disposition of Claims					
4)	is/are withdraw ed. ed. ted to.	n from consideration.			
Application Papers		•			
9) The specification is objected 10) The drawing(s) filed on Applicant may not request that Replacement drawing sheet(s) 11) The oath or declaration is obj	_ is/are: a) ☐ acce any objection to the d including the correction	pted or b) objected to be rawing(s) be held in abeyand on is required if the drawing(s	ce. See 37 CFR 1.85(a).	1.121(d). -152	
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a) All b) Some * c) No 1. Certified copies of the 2. Certified copies of the	ne of: priority documents priority documents copies of the priorit ternational Bureau (have been received. have been received in Ap y documents have been r (PCT Rule 17.2(a)).	plication No eceived in this National Sta	age	
Attachment(s) Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing R Information Disclosure Statement(s) (PTO Paper No(s)/Mail Date		Paper No(s)/	mmary (PTO-413) Mail Date ormal Patent Application (PTO-15	2)	
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The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 15 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Li (5,835,678) taken in view of Zhao (6,210,485). It is noted that Li (5,835,678) is a C-I-P of Li (5,835,677), which was cited in the rejection of the previous office action. Li (Fig. 1) discloses a CVD apparatus having a CVD reaction chamber connected to a vaporizer for vaporizing CVD source materials. The vaporizer (Fig. 2) includes a heated chamber having an inlet and a heat conductive chamber wall that houses the baffles 52, 54 and 56. A spray nozzle 24 is located to spray CVD precursor source materials into the chamber through the inlet, and a plate contacting and locating the tip end of the nozzle (see the baffle plate for distributing inert gas illustrated in Fig. 2 but unlabeled). It is noted that "locate" is defined as "to determine or indicate the place, site or limits of", and the plate of Li indicates the place, site or limits of the nozzle. Cooling jacket 26 is a cooling block that is provided for cooling the nozzle (see col. 8, lines 14-17). Li (5,835,678) (see Figs. 4, 5A and 5B and col. 12, line 1 to col. 13, line 4) makes clear that the cooling block is intended to be in physical contact with the nozzle. In view of Li's (5,835,678) description of his Figs. 4, 5A and 5B, it would have been inherent or at least obvious that the cooling block of Fig. 2 was in physical contact with the nozzle of Fig. 2. Fig. 2 of Li also illustrates a middle portion (where thermocouple 32 is located) that is positioned between and connects the lower heated portion of Li's vaporizer with

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the cooled upper portion of the vaporizer. Li does not disclose the middle portion as designed or intended to act as a heat conduction restricting region, and in view of the schematic nature of patent drawings it is not clear from Li's Fig. 2 that the middle portion is a heat conduction restricting region. Zhao (Figs. 4 and 5) also discloses a vaporizer having a lower heated vaporization chamber and an upper cooled liquid delivery section. Zhao teaches (col. 7, lines 34-45, and col. 9, lines 29-35) that a middle 'neck" portion located between and connecting the heated lower portion and cooled upper portion should be narrow to act as a heat conduction restricting region. Both the neck and the space around the neck act as a heat conduction restricting region. In view of the teachings of Zhao, it would have been obvious to one skilled in the art to intentionally design the middle portion of Li's vaporizer to be narrow enough to act as a heat conduction restricting region.

Claims 16 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Li (5,835,678) taken in view of Zhao and Onabe (JP 09-143738). Li (5,835,678) discloses the use of an ultrasonic nozzle to spray his liquid material to be vaporized, and he does not discuss the use of a nozzle having first and second coaxial tubes as claimed in claims 14, 16 and 18. Onabe (Figs. 1 and 2), however, teaches that a source material can be atomized and sprayed by a nozzle having first and second coaxial tubes. Also, Zhao teaches the use of two coaxial tubes for spraying a source material. It would have been obvious to one skilled in the art to modify the apparatus of Li (5,835,678) by substituting a spray nozzle having first and second coaxial tubes of the type taught by Zhao and Onabe for the ultrasonic spray nozzle of Li because they

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teach that such a coaxial spray nozzle is an alternate and successful way of spraying source materials into a vaporizer.

Regarding claims 15 and 17, applicants have argued that the cooling jacket 26 of Li (5,835,677) is not in direct contact with Li's nozzle 24. It is noted, however, that Li (5,835,678), in his discussion of Figs. 4, 5A and 5B, indicates that his cooling block is intended to be in physical contact with his nozzle.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Richard Bueker whose telephone number is (571) 272-1431. The examiner can normally be reached on 9 AM - 5:30 PM, Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (571) 272-1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Ruluna Bulun Richard Bueker Primary Examiner Art Unit 1763